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PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Byung Kwon AHN et al.

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Serial No.: 10/603,306

Group Art Unit: 2812

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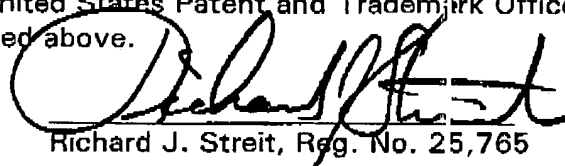
For: METHOD FOR FORMING CAPACITOR OF SEMICONDUCTOR DEVICE

**Certification under 37 C.F.R. 51.8(a)**

The USPTO Fax No. (703) 872-9318 (TC2800: Before Final)

Date of Fax Transmittal: January 22, 2004

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted to the United States Patent and Trademark Office to the fax number and on the date indicated above.



Richard J. Streit, Reg. No. 25,765

Commissioner for Patents  
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Alexandria, VA 22313-1450

**APPOINTMENT OF ASSOCIATE ATTORNEY**


Dear Sir:

The undersigned Attorney for Applicant in the above identified application for Letters Patent, hereby appoints **Woochoon William Park, Reg. No. P-55,523** as my Associate Attorney, to prosecute this application, to make alterations and amendments therein, to receive the patent, and to transact all business in the United States Patent & Trademark Office connected therewith.

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